

Practical course on Transmission Electron Microscopy

Where: Newtonstrasse 15, TEM lab 0'503

When: Monday, 3 p.m. - 7 p.m., course accompanies the lecture on electron microscopy and usually starts at 4th week of the semester

Topics:

1. *Microscope: general introduction*

- Vacuum system, cooling water supply, electron gun, lenses, sample holders, camera system

2. *Alignment (part 1): Illumination*

- Generation of an electron beam
- Alignment of electron source, condenser aperture, beam centering
- Beam centering for different spot sizes

3. *Alignment (part 2): Illumination*

- Recall of alignment (part 1)
- Adjustment of Pivot points
- Stigmatism of condenser system

4. *Alignment (part 3): Image formation*

- Recall of alignment (part 1 and 2)
- Finding the specimen
- Adjustment of eucentric height, focus, under and over focus
- Current centre, objective stigmatism

5. *Transmission electron diffraction*

- Alignment for diffraction mode, adjustment of objective aperture and selected area aperture
- Zone axis orientation of a single crystalline specimen, Bragg condition, Laue condition

6. *Diffraction contrast TEM imaging*

- Recall of diffraction conditions
- Alignment for bright-field, dark-field, and weak-beam TEM imaging
- Bright-field and dark-field TEM imaging

7. *High resolution TEM*

- High-resolution TEM imaging: specimen alignment, diffraction condition, image processing
- Components of Spectrometer, X-ray spectrum, quantitative analysis, scanning TEM mode for point spectrum, line scan, elemental map

8. *Convergent beam electron diffraction*

- Alignment for convergent beam electron diffraction
- Higher order Laue zone lines, Large-angle CBED

9. Analytical TEM (part1) – Energy dispersive X-ray spectroscopy (EDXS)

- Components of an EDX spectrometer
- Demonstration: spectrum acquisition, spectrum analysis, point spectrum, line scan, elemental map

10. Analytical TEM (part2) – Electron energy loss spectroscopy (EELS)

- Components of an EEL spectrometer
- Demonstration: spectrum acquisition, spectrum analysis, point spectrum, line scan, area scan, elemental mapping by EFTEM